

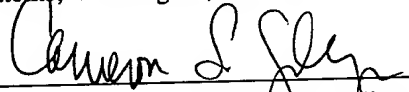


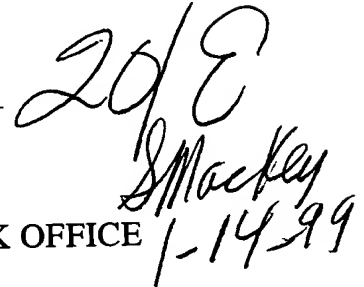
- 1 -

Docket: 0756-1638

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on December 31, 1998.

  
Cameron S. Gilligan



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Hisashi OHTANI et al. )  
Serial No. 08/807,737 ) Art Unit: 2813  
Filed: February 27, 1997 ) Examiner: M. Sulsky  
For: METHOD FOR MANUFACTURING )  
SEMICONDUCTOR DEVICE ) Date: December 31, 1998

**AMENDMENT**

Honorable Assistant Commissioner for Patents  
Washington, D.C. 20231  
Sir:

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JAN 11 1999  
GROUP 2100

In response to the Office Action of August 31, 1998, please amend the subject application as follows.

**IN THE CLAIMS:**

Please amend claims 19, 24, and 29 as follows:

01/07/1999 CHONG  
02 FC:103  
03 FC:102  
00000092 08807737  
182.00  
78.00